
CORRIGENDUM-III

No. IITMANDI/S&P/PUR-50/2019-20/5232-33

Date: 24.07.2019

To

1. Institute Website IIT Mandi
2. Central Public Procurement Portal.

Sub: -Corrigendum to NIT No. IITMANDI/S&P/PUR-50/2019-20/2545-2546, dated 03rd June, 2019 for the supply of "Semi-Automated wafer Cleaning Wet Bench/ Station".

The Last date for submission of Tender has been extended from **24th July, 2019 to 07 August, 2019 till 11:00 A.M.** due to non-receipt of minimum no. of required bids.

Date for **Technical Bid opening** has been extended from **25th July, 2019 to 08th August, 2019 at 11:00 A.M.** For any technical queries & clarification regarding the tender, the bidders are requested to contact our office through e-mail: satinder@iitmandi.ac.in.

Those who have already sent their bids need not bid again, and their earlier bids will be considered.

All other terms and conditions remain the same.

Sd/-
**Assistant Registrar
(Stores & Purchase)**